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1050 U.S. PTO

JC997 U.S. PTO
09/903601
07/12/01

ADAMS & WILKS
ATTORNEYS AND COUNSELORS AT LAW
50 BROADWAY
31st FLOOR
NEW YORK, NEW YORK 10004

BRUCE L. ADAMS
VAN C. WILKS*

JOHN R. BENEFIEL*
PAUL R. HOFFMAN
TAKESHI NISHIDA
FRANCO S. DE LIGUORI*

*NOT ADMITTED IN NEW YORK
*REGISTERED PATENT AGENT

BY EXPRESS MAIL ON
July 12, 2001
(EK 825 216 945 US)

RIGGS T. STEWART
(1924-1993)

TELEPHONE
(212) 809-3700

FACSIMILE
(212) 809-3704

Box PATENT APPLICATION
ASSISTANT COMMISSIONER FOR PATENTS
Washington, DC 20231

RECORD OF TRANSMITTAL

INVENTORS: (1) Ryoichi MATSUOKA

TITLE: SEMICONDUCTOR WAFER PATTERN SHAPE EVALUATION METHOD AND
DEVICE

DOCKET NO: S004-4330

S I R:

Kindly find enclosed herewith for filing the documents
checked below. Any fees or charges not covered by the
accompanying check should be charged to our Deposit Account
No. 01-0268.

APPLICABLE ITEMS CHECKED:

XX PATENT APPLICATION (pages 1-12 of specification, 16
claims (pages) 10-12 and abstract of the
disclosure (page 13)

DESIGN APPLICATION (specification, claim, declaration and
power of attorney and photograph(s))

XX FORMAL DRAWINGS (5 sheets) (NI A4)

INFORMAL DRAWINGS (sheets)

RECORDATION FORM COVER SHEET and ASSIGNMENT
(to be recorded and returned to the undersigned)

XX PRIORITY CLAIM - applicant(s) claim the benefit of
priority of the following application(s):

Japanese Patent Appln. No. 2000-214847
filed July 14, 2000

Japanese Patent Appln. No.
filed

Japanese Patent Appln. No.
filed

Japanese Patent Appln. No.
filed

XX PRIORITY DOCUMENT(s)

 Enclosed XX Not Enclosed

 VERIFIED STATEMENT TO ESTABLISH SMALL ENTITY STATUS

XX EXPRESS MAIL CERTIFICATION

 OTHER -

XX FEE

A check is enclosed for the following official fees:

	Large Entity	Small Entity
<u>XX</u> Basic Filing Fee	\$ 710.00	\$
<u> </u> Independent Claims in Excess of 3	\$	\$
<u> </u> Total Claims in Excess of 20	\$	\$
<u> </u> Multiple Claim Fee	\$	\$
<u> </u> Assignment Recordal Fee	\$	\$
TOTAL	\$ 710.00	\$

Respectfully submitted,

ADAMS & WILKS
Attorneys for Applicant(s)

50 Broadway
31st Floor
New York, NY 10004
(212) 809-3700

By: Bruce L. Adams
Reg. No. 25,386

Re: New patent application of Ryoichi MATSUOKA

for SEMICONDUCTOR WAFER PATTERN SHAPE EVALUATION METHOD AND
DEVICE

comprising transmittal letter, title, specification (pgs.1-12),
16 claims (pgs.10-12), abstract of the disclosure (pg.13), 5
sheets of formal drawings containing thereon Figs. 1-5, express
mail certification and check in the amount \$710.00

Attorney's Docket No: S004-4330

EXPRESS MAIL CERTIFICATION UNDER 37 CFR §1.10

Express Mail Tracking Number: EK 825 216 945 US

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Feliciano De Carvalho